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Date: June 9, 2003

TO: Examiner Steven H. Versteeg (703) 872-9311
Art Unit: 1753

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Subject Matter: 09/ 976,082 Attorney Doc: 67,200-530

Message:

Total number of pages sent: - 13 - (including this cover sheet)

JUN 10 2003

GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chung-En Kao

Group Art Unit: 1753

Serial No.: 09/976,082

Examiner: Steven H. Versteeg

Filed: Oct. 12, 2001

In Response to Office Action
Dated: April 7, 2003For: Apparatus And Method For Self-Centering A Wafer
In A Sputter Chamber

Attorney Docket No.: 67,200-530

Certificate of Facsimile

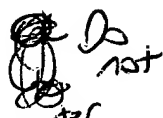
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no. (703) 872-9311 on June 9, 2003.


Kathy DixonREQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to a final Office Action mailed April 7, 2003, please enter the following amendments and consider the following remarks.

5/B
(N.E.)
W.M.
7/11/03
SHV
July 14, 2003